



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 22, 2026

IGI Report Number

LG829614233

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

PRINCESS CUT

Measurements

6.50 X 6.49 X 4.70 MM

GRADING RESULTS

Carat Weight

1.76 CARAT

Color Grade

D

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

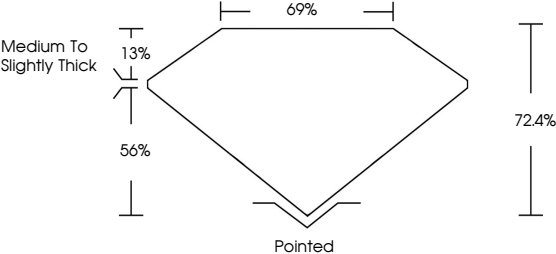
Inscription(s)

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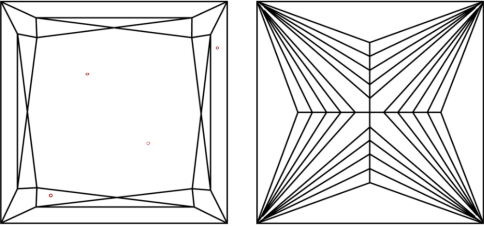
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used



COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS¹⁻² VS¹⁻² SI¹⁻² I¹⁻³

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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PRINCESS CUT

6.50 X 6.49 X 4.70 MM

Carat Weight

1.76 CARAT

D

Color Grade

D

VS 1

Clarity Grade

VS 1

72.4%

Depth

72.4%

69%

Table

69%

Medium to Slightly Thick

Girdle

Medium to Slightly Thick

Pointed

Culet

Pointed

EXCELLENT

Polish

EXCELLENT

EXCELLENT

Symmetry

EXCELLENT

NONE

Fluorescence

NONE

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www.igi.org